

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
1	BRS	L1	17	duv and \$5lithography and low adj k adj dielectric and (silicon adj oxycarbide with hydrogen\$5 or sioc\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/31 03:20			
2	BRS	L2	12	duv and \$5lithography and low adj k adj dielectric and (silicon adj oxycarbide with hydrogen\$5 or sioc\$4H)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/05/31 03:20			